

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 1792**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto NAKADATE

Group Art Unit: 1792

Application No.: 10/782,947

Examiner: B. TRAN

Filed: February 23, 2004

Docket No.: 118824

For: MASK, MANUFACTURING METHOD FOR MASK, MANUFACTURING  
APPARATUS FOR MASK, METHOD FOR MAKING FILM OF LIGHT-EMITTING  
MATERIAL, ELECTROOPTICAL APPARATUS AND ELECTRONIC APPARATUS

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the April 20, 2009 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**